



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric NEYRET et al.

Confirmation No.

Application No.:

Group Art Unit:

Filing Date:

Examiner:

For: PREVENTIVE TREATMENT METHOD  
FOR A MULTILAYER SEMICONDUCTOR  
WAFER

Attorney Docket No.: 4717-10100

**POWER OF ATTORNEY BY ASSIGNEE  
AND EXCLUSION OF INVENTOR(S) UNDER 37 C.F.R. 3.71**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The undersigned assignee of the entire interest in the above-identified subject application hereby appoints Allan A. Fanucci (Reg. No. 30,256) and Daniel J. Hulseberg (Reg. No. 36,554) of WINSTON & STRAWN LLP (Customer No. 28765) to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith.

Please direct all correspondence for this application to Customer No. 28765 to the attention of Allan A. Fanucci (telephone 212-294-3311, facsimile 212-294-4700).

An assignment of the entire interest in the above-identified subject application:

- ☒ is submitted herewith for recording and a copy is attached.  
☐ was submitted for recordation on \_\_\_\_\_ and a copy is attached.  
☐ was recorded on \_\_\_\_\_ at Reel \_\_\_\_\_, Frame \_\_\_\_\_.

The undersigned has reviewed this assignment and, to the best of his/her knowledge, title is in the assignee seeking to take action in this application and that he/she is empowered to act on its behalf.

ASSIGNEE: S.O.I. TEC SILICON ON INSULATOR TECHNOLOGIES S.A.

Signature: \_\_\_\_\_

Date of Signature: \_\_\_\_\_

Typed Name: \_\_\_\_\_

Position/Title: \_\_\_\_\_

Address: \_\_\_\_\_

Parc Technologique des Fontaines

F-38190 Bernin, France

## ASSIGNMENT

WHEREAS, each of

**Eric NEYRET**, a citizen of France, residing at  
2, rue Lesdiguières, 38360 Sassenage, France; and

**Christophe MALEVILLE**, a citizen of France, residing at  
90 Rue du Château, 38660 La Terrasse, France.

ASSIGNOR, is an inventor of the invention in **PREVENTIVE TREATMENT METHOD FOR A MULTILAYER SEMICONDUCTOR WAFER**, for which an application for a Patent of the United States, identified by Winston & Strawn LLP Docket No. 4717-10100

- ☒ is executed on even date herewith  
☐ was filed on \_\_\_\_\_ as Application No. \_\_\_\_\_.

WHEREAS, **S.O.I. TEC SILICON ON INSULATOR TECHNOLOGIES, S. A.** a French corporate body having a place of business at Parc Technologique des Fontaines, F-38190 Bernin, France, , ASSIGNEE, is desirous of obtaining each inventor's entire right, title and interest in, to and under the said invention and the said application.

NOW, THEREFORE, in consideration of the sum of One Dollar (\$1.00) to each inventor in hand paid, and other good and valuable consideration, the receipt of which is hereby acknowledged, each ASSIGNOR has sold, assigned, transferred and set over, and by these presents does hereby sell, assign, transfer and set over, unto the said ASSIGNEE, its successors, legal representatives and assigns, his or her entire right, title and interest in, to and under the said invention, and the said United States application and all divisions, renewals and continuations thereof, and all Patents of the United States which may be granted thereon and all reissues and extensions thereof;

And each ASSIGNOR hereby authorizes and requests the Commissioner of Patents and Trademarks of the United States, to issue the same to the said ASSIGNEE, its successors, legal representatives and assigns, in accordance with the terms of this instrument;

And each ASSIGNOR hereby covenants and agrees that he or she has the full right to convey the entire interest herein assigned, and that he or she has not executed, and will not execute, any agreement in conflict herewith;

And each ASSIGNOR hereby further covenants and agrees that he or she will communicate to the said ASSIGNEE, its successors, legal representatives and assigns, any facts known to him or her respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, and reissue applications, make all rightful oaths, and generally do everything possible to aid the said ASSIGNEE, its successors, legal representatives and assigns, to obtain and enforce proper protection for said invention;

And each ASSIGNOR hereby authorizes the ASSIGNEE's patent attorney to complete this form by the addition of the application number, application filing date, and attorney docket number, if necessary.

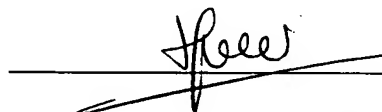
In witness whereof, each inventor has affixed his or her signature.

Date Feb. 23<sup>rd</sup>, 2004



Eric NEYRET

On Feb 23<sup>rd</sup>, 2004, before me, E. HUYGHE, Witness, appeared **Eric NEYRET**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.



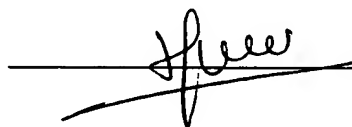
Witness

Date Feb 23<sup>rd</sup>, 2004



Christophe MALEVILLE

On Feb 23<sup>rd</sup>, 2004, before me, E. HUYGHE, Witness, appeared **Christophe MALEVILLE**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.



Witness